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# The influence of stress and heat treatment on the magnetization of TbDyFe films

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### **Abstract**

Amorphous (Tb<sub>0</sub> <sub>3</sub>Dy<sub>0</sub>  $_2$ )<sub>43</sub>Fe<sub>57</sub> films were prepared by DC magnetron sputtering. After annealing at 400°C for 1 h, a small amount of (Tb,Dy)Fe, crystal grain precipitated from the amorphous film. The magnetization in the as-deposited film and the film treated at 200 $^{\circ}$ C is nearly isotropic. After treatment at 300 and 400°C, the films showed anisotropic magnetization with the easy axis parallel to the film surface. For the as-deposited films, stress applied to the films makes it magnetize slightly. Annealed below 200°C, the coercivity of the films did not change. After 300°C heat treatment, the coercivity,  $H_c$ , reduced because of the release of stress in the film. For the films with 400 $\degree$ C heat treatment,  $H_c$  increased because partial crystallization occurred in the film.  $\degree$  2000 Elsevier Science S.A. All rights reserved.

*Keywords*: Magnetostriction; Amorphous; Magnetization; Coercivity

TbDyFe alloys shows giant magnetostriction. The main characteristic of this material — change of length in an applied magnetic field — implies that it may be used for **2. Experimental** microsensors, microactuators, or tunable surface-acousticwave devices [1]. The major requirement for application in The  $(Tb_{0.3}Dy_{0.7})_{43}Fe_{57}$  films were prepared by DC microsystem technology is that these materials should be magnetron sputtering. The  $(Tb_{0.3}Dy_{0.7})_xFe_{1-x}$  alloy was prepared in the form of film and have sufficient magneto-<br>used as target. By adjusting the Fe content in striction at low magnetic fields, and the films have to be films with the desired composition were prepared. The magnetically soft. Based on these requirements, the films substrates were glass slides or copper plates with a should be amorphous to reduce the coercivity. According thickness of 0.05 mm without heating during sputtering.<br>to previous research on the Tb<sub>x</sub>Dy<sub>1-x</sub> film, it is amorphous The sputtering parameters were as follows: bas to previous research on the Tb<sub>x</sub>Dy<sub>1-x</sub> film, it is amorphous The sputtering parameters were as follows: base pressure, when x is in a special range [2,3]. Even if the film is  $10^{-3}$  Pa;  $P_{Ar}$ , 0.5, Pa and sputtering p amorphous, it possesses magnetic anisotropy due to the thickness of the film was  $2-5 \mu m$ . The sputtering rate was influence of the composition of the film, preparation 0.4 nm/s. In order to investigate the influence of stress on condition, stress in the film, and so on. The films with the magnetic anisotropy of the films, the copper substrates parallel anisotropy (easy magnetization axis is parallel to were elastically arched during sputtering as shown in Fig. the surface of the film) are more suitable for use in 1. The degree of deformation of the substrates were microsystems because it they have large magnetostriction expressed as height (*h*). After the deposition, the Cu in low magnetic field which is parallel to the surface of the substrates returned to their original flat shape on relaxation films [4]. The goal of our research was to prepare the from the fixing clamps. So the compressive stress were amorphous films with parallel anisotropy. In this paper, the applied along the arched direction. Three kinds of de-

**1. Introduction** influence of stress and heat treatment on the magnetic anisotropy of the film is discussed.

used as target. By adjusting the Fe content in the target, formation were applied. The details are shown in Table 1.

The films were given subsequent vacuum heating treat-<br>\*Corresponding author. Tel.: +861-082-317-117; fax: +861-082-314-

*E-mail address:* xuhb@public.bta.net.cn (H. Xu). The magnetic properties of the films were measured at

<sup>871.</sup> ment at 200, 300, 400°C for 1 h.



Fig. 1. Schematic drawing of sample fixed during sputtering.

Table 1 Amount of deformation

Sample	n
no.	(mm)
$\mathcal{D}$	12
3	20



Fig. 2. X-ray diffraction diagram of amorphous sample 1 under different heat treatments.



 $(c)$ 

Fig. 3. Magnetization curve of the samples with different *h* values (a)  $h = 0$ ; (b)  $h = 12$  mm; (c)  $h = 20$  mm; p, magnetizing direction is parallel to the film surface; c, magnetizing direction is vertical to the film surface; pp, pc, two vertical directions lying in film surface.

room temperature by vibrating the sample magnetometer in **3. Results and discussion** a maximum applied field of 10 000 Oe. The composition of the films was measured by energy dispersive X-ray 3.1. *XRD result of films with different heat treatment* spectroscopy (EDX). The structure of the film was identified by X-ray diffraction (XRD). The composition of the film was close to



 $(e)$ 

Fig. 4. Magnetization curve with different heat treatment; (a) sample 1, 200°C, 1 h; (b) sample 1, 300°C, 1 h; (c) sample 3, 200°C, 1 h; (d) sample 3,  $300^{\circ}$ C, 1 h; (e) sample 3,  $400^{\circ}$ C, 1 h; p, magnetizing direction is parallel to the film surface; c, magnetizing direction is vertical to the film surface; pp, pc, two vertical directions lying in film surface.

 $(Tb_{0.3}Dy_{0.7})_{43}Fe_{57}$  from the results of EDX. Fig. 2 shows the X-ray diffraction patterns of sample 1 with different heat treatments.

From the XRD results, it can be seen that the asdeposited films were amorphous, and this state was stable up to 300 $^{\circ}$ C. After 400 $^{\circ}$ C treatment, a weak (Tb,Dy)Fe<sub>2</sub> peak appeared indicating that primary crystallization occurred in the film.

## 3.2. *Magnetization*, *coercivity and anisotropy of the films with different treatment*

Fig. 3 shows the magnetization curves of as-deposited films with different degrees of shape change. It shows that Fig. 5. Coercivity of the film with different heat treatments. three films are of almost equal magnetization. The magnetization curve of samples 1 and 2 are almost similar, but slightly different from sample 3, which seems to be more **4. Conclusion** difficult to magnetize in a low magnetic field. The deformation of sample 3 was the largest among three films, Amorphous ( $Tb_{0.3}Dy_{0.7}$ )<sub>43</sub>Fe<sub>57</sub> films were prepared by so the applied compressive stress in the films on the DC magnetron sputtering. After annealing at 400° so the applied compressive stress in the films on the restoration of the substrates was higher compared with h, a small amount of (Tb,Dy)Fe, crystal grain precipitated other two films. It may be the large stress in the film which from the amorphous film. The magnetization in the asmake it more difficult to magnetize. The coercivity of all deposited film and the film treated at  $200^{\circ}$ C is nearly

3 under different heat treatments. After being annealed at parallel to the film surface. For the as-deposited films,  $200^{\circ}$ C for 1 h, no change in the magnetization curve was stress applied on the films made it magnetize slightly. observed in sample 1 compared with as-deposited films. Annealed below 2008C, the coercivity of the films did not However, the magnetization curve of sample 3 changed change. After the 300 $^{\circ}$ C heat treatment, the coercivity,  $H_c$ , compared with the as-deposited film. The film magnetized reduced because of the release of stress in compared with the as-deposited film. The film magnetized more easily at a low magnetic field. This is the result of films undergoing  $400^{\circ}$ C heat treatment,  $H_c$  increased part of the stress in the film being released. After 300 and because partial crystallization occurred i part of the stress in the film being released. After 300 and  $400^{\circ}$ C treatments, the parallel anisotropy appeared in all the samples.

Fig. 5 shows the change of coercivity,  $H_c$ , with the **Acknowledgements** annealing temperature. For all samples, the  $H_c$  value of the film treated at 200°C did not present any obvious changes This project is supported by National Natural Science<br>
compared with the as-deposited films After annealing at Foundation of China (NSFC). compared with the as-deposited films. After annealing at 300 $^{\circ}$ C, the  $H_c$  value of all the films was reduced, and it increased again with heat treatment at  $400^{\circ}$ C. According to the XRD result, the film is still amorphous, annealed at **References**  $300^{\circ}$ C for 1 h. The  $400^{\circ}$ C heat treated films were partially crystallized. Therefore the change of coercivity with the [1] F. Schatz, M Hirsher, M Schnell, G Flik, H Krorndller, J. Appl. 2011 Phys. 76 (9) (1994) 5380. annealing temperature was caused by the release of stress<br>in the film. The increased of the film coercivity with the<br>400°C heat treatment is the result of partial crystallization (1988) 1713. of the films. [4] E. Quandt, J. Alloys. Comp. 258 (1990) 126.



the films are  $\leq$  200 Oe. isotropic. After being treated at 300 and 400 $^{\circ}$ C, the films Fig. 4 shows the magnetization curves of samples 1 and showed anisotropic magnetization with the easy axis

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